Notice of Allowability	Application No.	Applicant(s)
	10/649,875	YAMAGUCHI ET AL.
	Examiner	Art Unit
	Christopher M. Keehan	1712
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to the amendment filed 3/17/05.		
2. The allowed claim(s) is/are <u>1-6 and 10-15</u> .		
3. The drawings filed on are accepted by the Examiner.		
4.		
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview Summary Paper No./Mail Da 8), 7. ☐ Examiner's Amendr	te

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DETAILED ACTION

Reasons for Allowance

Claims 1-6 and 10-15 are allowed. The prior art of record does not appear to teach or disclose a perfluoropolyether modified silane as claimed that is vacuum deposited. Invie et al. (6,277,485 B1) disclose sputtering an oxide layer prior to applying the silane layer, but do not teach or disclose vacuum depositing or sputtering the silane layer. In addition, applicant has shown experimental results in Examples 1 and 2 to show that the drop angle and peel strength decreases when the silane layer (Example 2) is applied by vacuum deposition. This appears to distinguish the product of applicant's from the product of Invie et al. Applicant has added independent claim 10, which also contains the vacuum depositing step, and claim 12, which is the process of making thereof.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Christopher M. Keehan whose telephone number is (571) 272-1087. The examiner can normally be reached on Monday-Friday, from 6:30 to 3:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Randy P. Gulakowski can be reached on 571-272-1302. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Christopher Keehan Cuu

May 3, 2005

RANDY GULAKOWSKI
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 1700